

## International Symposium on Electrostatics and Non-Thermal Plasma 2013

--- In memory of Prof. M. Sato---

### Preface:

This international symposium is devoted to memory of late Professor Emeritus M. Sato of Gunma University. He made significant contribution in the field of electrostatics, especially to create the field of application of electrical discharge in liquid. Prof. Sato has many colleagues and students who wish to express their gratitude. In conjunction with the annual meeting of Institute of Electrostatics Japan, this international symposium is planned by IESJ according to the request.

### International organizing committee:

Prof. M. Chen	Anhui University of Science and Technology, China
Prof. S. Katsura	Gunma University, Japan
Dr. S. J. Kim	KIMM, Korea
Prof. J. Li	Dalian Institute of Technology, China
Prof. J. Mizeraczyk	Polish Academy of Sciences, Poland
Prof. A. Mizuno	Toyohashi University of Technology, Japan
Prof. T. Oda	University of Tokyo, Japan
Prof. T. Oshima	Gunma University, Japan
Prof. B. Sung	Dalian Maritime University, China
Prof. F. Tochikubo	Tokyo Metropolitan University, Japan
Prof. G. Touchard	University of Poitiers, France
Dr. K. Urashima	NISTEP, MEXT, Japan
Prof. Y. Wu	Dalian Institute of Technology, China
Prof. T. Yamamoto	Tokyo City University, Japan
Prof. K. Yan	Zhejiang University, China
Prof. K. Yasuoka	Tokyo Institute of Technology, Japan

Date: Sept.10 and 11, 2013

Place: Chiba University, Yayoi 1-33, Inage-ku, Chiba, 263-8522, Japan  
<http://www.chiba-u.jp/access/nishichiba/>

### Submission of the contribution:

Deadline: July 29

Manuscript in Word and in PDF files should be sent to:

Institute of Electrostatics Japan [iesj@iesj.org](mailto:iesj@iesj.org) and  
Program chair Prof. A. Mizuno [mizuno@ens.tut.ac.jp](mailto:mizuno@ens.tut.ac.jp)

Use the template:

<http://www.iesj.org/html/service/ijpest/ijpest-paper-format.doc>

The template is the same as that of IJPEST. Length should be 6 pages maximum.

The contribution will be reviewed for publication in IJPEST.

Registration: On site, 5,000 JPY

Web-site: <http://www.iesj.org/>